

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Mitsuru Ozono et al.
Serial No.: N/A
Filing Date: Herewith
Title: "METHOD AND APPARATUS FOR PICKING UP
SEMICONDUCTOR CHIP AND SUCTION AND
EXFOLIATION TOOL USED THEREFOR
Docket No.: 35857

INFORMATION DISCLOSURE STATEMENT

Mail Stop PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with Rule 56, applicants are aware of the publications listed in the enclosed copy of Patent Office Form 1449. A copy of each of the publications is enclosed herewith.

Respectfully submitted,
PEARNE & GORDON LLP

By: _____

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July 15, 2003

Express Mail Label No. EV341098585US

Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 35857	SERIAL NO. N/A
INFORMATION DISCLOSURE CITATION BY APPLICANT <i>(USE SEVERAL SHEETS IF NECESSARY)</i>		APPLICANT: Mitsuru Ozono et al.	
		FILING DATE: Herewith	GROUP ART UNIT:

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date If Appropriate
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	K	05-335405	12/1993	Japan			English abstract
	L	06-061347	3/1994	Japan			English abstract
	M	11-274181	10/1999	Japan			English abstract
	N	2001-118862	4/2001	Japan			cited on pg 2 of spec.
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)
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Examiner:	Date Considered
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*Examiner: Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.